

# JOIN US FOR CVD 2008

## SCIENCE-ENGINEERING-TECHNOLOGY

**4-5 MARCH**  
**WASHINGTON, D.C.**

### WHAT IS CONGRESSIONAL VISITS DAY?

CVD is a two-day annual event in Washington, D.C., that brings together scientists, engineers, researchers, educators, and technology executives to raise visibility and support for science, engineering and technology. Uniquely multi-sector and multi-disciplinary, CVD is coordinated by a coalition of companies, professional societies and educational institutions, and is open to all who support research and development activities. The event consists of a series of briefings, a Congressional reception, and highlighted by meetings with your Congressional delegation.

### OBJECTIVE

To underscore the long-term importance of science and technology that supports the Nation's global competitiveness, through meetings with Members of Congress, Congressional staff, key Administration officials and other decision makers.



### CORE MESSAGES

Balanced Federal investment in science, engineering and technology (SET) is fundamental to the future of our nation's prosperity

Effective competitiveness and innovation policies will sustain U.S. technological leadership and encourage the development of a skilled, creative and competitive workforce.

### HOW TO PARTICIPATE

You can register online at:

[www.ieeeusa.org/policy/cvd/registration.html](http://www.ieeeusa.org/policy/cvd/registration.html)

or complete the attached registration form and send it to:

Deborah Rudolph, IEEE-USA

Fax: 202-785-0835

E-Mail: [d.rudolph@ieee.org](mailto:d.rudolph@ieee.org)

CVD Website: [www.aas.org/policy/cvd](http://www.aas.org/policy/cvd)

**Registration Deadline: 20 February 2008**